

JUL 20 2006

Docket No. 031948-6

Serial No. 10/760,295

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Kenji ARAI et al.

Serial No. 10/760,295

Filed: 1/21/2004

For: METHOD OF PROTECTING A  
SEMICONDUCTOR INTEGRATED  
CIRCUIT FROM PLASMA DAMAGE

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Group Art Unit: 2825

Examiner: Yelena Rossoshek

Confirmation No. 9845

Date: July 20, 2006

CERTIFICATE OF MAILING OR TRANSMISSION  
[37 CFR 1.8(a)]

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Signature: \_\_\_\_\_

Name: Jeannie Saxton

## AMENDMENT

Mail Stop \_\_\_\_\_  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 20, 2006, please amend the above identified application as follows.

07/21/2006 TL0111 00000069 192380 10760295

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